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## APPLICANTS

Seon-Mee Cho, Beaverton, OR;

Easwar Srinivasan, Beaverton, OR;  
Brian G. Lu, Fremont, CA;David Mordo, Cupertino, CA;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CIP of 10/672,311 09/26/2003

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## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*✓ done*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/28/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY OR	SHEETS DRAWING 5	TOTAL CLAIMS 53	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i> Initials <i>11</i>				

## ADDRESS

022434  
BEYER WEAVER & THOMAS LLP  
P.O. BOX 70250  
OAKLAND , CA  
94612-0250

## TITLE:

Method and apparatus for UV exposure of low dielectric constant materials for porogen removal and improved mechanical properties

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